

# **Low Energy Ion Beam And Plasma Modification Of Materials: Volume 223 (MRS Proceedings)**

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## **Curriculum Vitae of Professor Stephen J -**

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### **Nuclear Instruments and Methods in Physics -**

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### **Fundamentals of Ion- Material Interactions -**

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### **A review of: LOW ENERGY ION BEAM AND PLASMA -**

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**Publications - Plasma Applications Group -**

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